

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Yuichiro MATSUO et al. Group Art Unit: 1753

Examiner: Edna Wong Serial Number: 10/715,403

Filed: November 19, 2003 Confirmation Number: 1169

For: NEGATIVE ION GENERATING MEDIUM AND ITS

MANUFACTURING METHOD

Attorney Docket Number: 032114 Customer Number: 38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 26, 2005 for two (2) months from July 26, 2005 to September 26, 2005.

Attached please find a check in the amount of \$450.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

with

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September 22, 2005